# Kraig J. Andrews

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#### Education

• Wayne State University
Ph.D. Physics
Detroit, MI
2014 – Present

• Wayne State University
M.Sc. Physics

Detroit, MI
2014 – 2017

• Michigan State University
B.Sc. Physics

East Lansing, MI
2010 – 2014

• Michigan State University
B.Sc. Astrophysics

East Lansing, MI
2010 – 2014

# **Research Experience**

• Nano Fabrication and Electron Transport Laboratory Wayne State University, Detroit, MI Graduate Research Assistant (Advisor: Dr. Zhixian Zhou) 2015 – Present

- Fabricate field-effect transistors using two-dimensional semiconductors to investigate their intrinsic transport properties.
- Develop novel techniques for making low-resistance Ohmic contacts to a wide variety of two-dimensional semiconductors.
- - Investigate methods for surface modification of two-dimensional semiconductors for the use of creating a new low-resistance Ohmic contact strategy.
- Interational Course on Computational Physics Delft, The Netherlands and East Lansing, MI Undergraduate Research Assistant (Advisors: Dr. Jos Thijssen, Dr. Phil Duxbury) 2014
  - A Joint collaboration with Technische Universiteit Delft and Michigan State University involving the development of computational models of various physical systems to model interactions of materials and optimize employed techniques.
- optimize employed techniques.

   Jenoptik Laser Technologies

  Brighton, MI
  - Contributed in development of a user interface for laser welding machine that allows user manipulation of robotic end-arm tooling
  - of robotic end-arm tooling.

     Incorporated microcontroller program via interfaced electronic devices and several developed algorithms
- Michigan State University
  Undergraduate Research Assistant (Advisor: Dr. Edward Brown)

  East Lansing, MI
  2012 2014
  - Research of neutron star evolution using various modeling tools and techniques.

to analyze physical data and feedback in real-time.

#### **Peer Review Publications**

Summer Intern

1. "High Performance WSe<sub>2</sub> Phototransistors with 2D/2D Ohmic Contacts." Tianjiao Wang, **Kraig Andrews**, Arthur Bowman, Tu Hong, Michael Koehler, Jiaqiang Yan, David Mandrus, Zhixian Zhou, and Ya-Qiong Xu. *Nano Letters*, (18)5:2766-2771. 2018.

## **Presentations**

- 1. "Palladium Diselenide as a New Two-Dimensional Electronic Material Beyond Silicon." Kraig Andrews, Arthur Bowman, Upendra Rijal, Amanda Haglund, David Mandrus, and Zhixian Zhou. Society of Vacuum Coaters TechCon, Orlando, FL. May 2018.
- 2. "Improved On-Off in Ratio Black Phosphorus Field-Effect Transistors with True Ohmic Contacts." Kraig Andrews, Arthur Bowman, Upendra Rijal, Michael Koehler, David Mandrus, and Zhixian Zhou. APS March Meeting, Los Angeles, CA. March 2018.
- 3. "High Mobility Palladium Diselenide Field-Effect Transistors Using Heaving n—Doped Graphene Contacts." Arthur Bowman, **Kraig Andrews**, Upendra Rijal, Amanda Haglund, David Mandrus, and Zhixian Zhou. APS March Meeting, Los Angeles, CA. March 2018.
- 4. "Measuring the Barrier Height at Transition Metal Dichalcogenide Heterojunctions." Upendra Rijal, Arthur Bowman, Kraig Andrews, Michael Koehler, David Mandrus, and Zhixian Zhou. APS March Meeting, Los Angeles, CA. March 2018.
- 5. "High-Performance Top-Gated WSe<sub>2</sub> Transistors with Two-Dimensional Ohmic Contacts." **Kraig Andrews**, Upendra Rijal, Arthur Bowman, Hsun-Jen Chuang, Sagar Paduel, Michael Koehler, David Mandrus, and Zhixian Zhou. 41<sup>st</sup> Annual Symposium American Vacuum Society- Michigan Chapter, Ann Arbor, MI. May 2017.
- 6. "Substrate Dependence of Hall and Field-Effect Mobilities in Few-Layer MoS<sub>2</sub> Field-Effect Transistors." Bhim Chamlagain, Perera Meeghage, Hsun-Jen Chuang, Arthur Bowman, Upendra Rijal, **Kraig Andrews**, Joseph Klesko, Charles Winter, and Zhixian Zhou. APS March Meeting, Boston, MA, March 2016.

#### **Awards and Honors**

Society of Vacuum Coaters (SVC) Student Sponsorship Award	2018
Wayne State Physics and Astronomy Department Travel Award	2017
Associated Students of Michigan State University (ASMSU) Research Travel Grant	2014

## **Professional Memberships**

Society of Vacuum Coaters 2018
American Physical Society 2017 – Present
Sigma Pi Sigma, Physics Honor Society 2013

## **Volunteer and Outreach Experience**

## **Teaching Experience**

Teaching Assistant, Wayne State University Teaching Assistant, Michigan State University Autumn 2014 – Summer 2018 Winter 2012 – Winter 2014

# **Core Technical Skills**

**Nanofabrication:** Atomic force microscopy (AFM), Electron beam lithography, Photolithography, Scanning electron microscopy (SEM), General clean room abilities (> 1000 hours), Physical vapor deposition (PVD), Plasma etching, Reactive ion etching (RIE)

**Languages & Software:** C++, Fortran, Java, JavaScript, Languages & Software: C++, Fortran, Java, Languages & Software: C++, Fortran, Languages & Software: C++, Fortran

Operating Systems: OS X, Linux OS, Microsoft Windows